

Notice of References Cited	Application/Control No. 10/590,835		Applicant(s)/Patent Under Reexamination OGAWA ET AL.	
	Examiner Peter Y. Choi		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0088025	05-2003	Ogawa et al.	525/107
*	B	US-4,719,045	01-1988	Ogawa et al.	252/609
*	C	US-5,188,896	02-1993	Suh et al.	428/397
*	D	US-2005/0263345	12-2005	Erickson et al.	181/290
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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